



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 18, 2024

IGI Report Number **LG665403990**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **8.85 X 8.84 X 6.13 MM**

GRADING RESULTS

Carat Weight **4.08 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

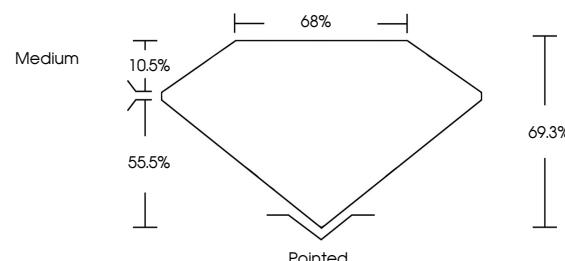
Fluorescence **NONE**

Inscription(s) **IGI LG665403990**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

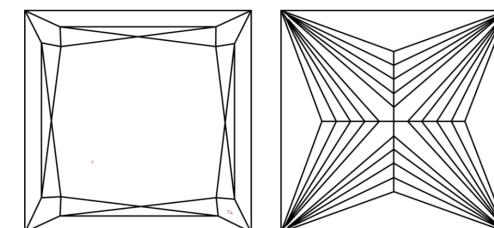
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

LG665403990
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT



November 18, 2024

IGI Report Number **LG665403990**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

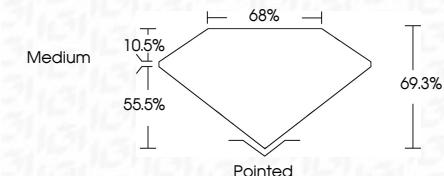
Measurements **8.85 X 8.84 X 6.13 MM**

GRADING RESULTS

Carat Weight **4.08 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG665403990**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

November 18, 2024	IGI Report No LG665403990
PRINCESS CUT	
8.85 X 8.84 X 6.13 MM	
Carat Weight	4.08 CARATS
Color Grade	D
Clarity Grade	VVS 2
Depth	68%
Table Grade	65%
Culet	Medium
Polish	Pointed
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG665403990

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa